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(54) **Method and apparatus for transferring heat from transducer array of ultrasonic probe**

Verfahren und Anordnung zur Übertragung von Wärme von einer Wandleranordnung in einer
Ultraschallkopf

Procédé et dispositif de transfert thermique pour une agencement de transducteurs dans une tête à
ultrason

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(56) References cited:

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Description

[0001] This invention generally relates to probes used in ultrasonic imaging of the human anatomy. In particular, the invention relates to techniques for limiting the build-up of transducer-generated heat on the exterior of an ultrasound probe.

[0002] A conventional ultrasonic probe comprises a transducer pallet which must be supported within the probe housing. As shown in FIG. 1, a conventional transducer pallet 2 comprises a linear array 4 of narrow transducer elements. Each transducer element is made of piezoelectric material. The piezoelectric material is typically lead zirconate titanate (PZT), polyvinylidene difluoride, or PZT ceramic/polymer composite.

[0003] Typically, each transducer element has a metallic coating on opposing front and back faces to serve as electrodes. The metallic coating on the front face serves as the ground electrode. The ground electrodes of the transducer elements are all connected to a common ground. The metallic coating on the back face serves as the signal electrode. The signal electrodes of the transducer elements are connected to respective electrical conductors formed on a flexible printed circuit board (PCB) 6.

[0004] During operation, the signal and ground electrodes of the piezoelectric transducer elements are connected to an electrical source having an impedance Z_5 . When a voltage waveform is developed across the electrodes, the material of the piezoelectric element compresses at a frequency corresponding to that of the applied voltage, thereby emitting an ultrasonic wave into the media to which the piezoelectric element is coupled. Conversely, when an ultrasonic wave impinges on the material of the piezoelectric element, the latter produces a corresponding voltage across its terminals and the associated electrical load component of the electrical source.

[0005] The transducer pallet 2 also comprises a mass of suitable acoustical damping material having high acoustic losses positioned at the back surface of the transducer element array 4. Backing layer 12 is acoustically coupled to the rear surface of the transducer elements, via the acoustically transparent PCB 6, to absorb ultrasonic waves that emerge from the back side of each element so that those waves will not be partially reflected and interfere with the ultrasonic waves propagating in the forward direction.

[0006] Typically, the front surface of each transducer element of array 4 is covered with at least one acoustic impedance matching layer 8. The impedance matching layer 8 transforms the high acoustic impedance of the transducer elements to the low acoustic impedance of the human body and water, thereby improving the coupling with the medium in which the emitted ultrasonic waves will propagate.

[0007] The transducer element array, backing layer and acoustic impedance matching layer are all bonded

together in a stack-up arrangement, as seen in FIG. 1. During assembly of the ultrasonic probe, the transducer stack-up must be held securely within the probe housing. Typically, this is accomplished by securing the transducer stack-up within a four-sided array case (not shown), i.e., a "box" having four side walls but no top or bottom walls. The array case is made of electrically conductive material and provides a common ground for connection with the ground electrodes of the transducer elements. The transducer stack-up is inserted into a recess in the array case until the bottom surface of the acoustic impedance matching layer 8 is flush with the bottom edge of the array case. The transducer stack-up is conventionally bonded inside the array case using epoxy. Then a second acoustic impedance matching layer is conventionally bonded to those flush bottom surfaces.

[0008] In conventional applications, each transducer element produces a burst of ultrasonic energy when energized by a pulsed waveform produced by a transmitter (not shown). The pulses are transmitted to the transducer elements via the flexible PCB 6. This ultrasonic energy is transmitted by the probe into the tissue of the object under study. The ultrasonic energy reflected back to transducer element array 4 from the object under study is converted to an electrical signal by each receiving transducer element and applied separately to a receiver (not shown).

[0009] The release of acoustic energy during transmission creates a thermal build-up in the probe due to acoustic losses being converted into heat. The amount of heat that can be allowed to build up on the exterior of an ultrasound probe must be within prescribed limits. Typically the limit is that the temperature on the patient contact surface of the probe cannot exceed 41°C or 16°C above ambient temperature, whichever is smaller. Most of the heat tends to build up immediately around the transducer elements, which are necessarily situated in the probe very close to the body of the patient being examined.

[0010] During assembly of an ultrasonic probe incorporating the structure of FIG. 1, transducer pallet 2 must be secured within the probe housing. The interior volume of the probe housing surrounding the transducer pallet is filled with thermally conductive potting material, e.g., heat-conductive ceramic granules embedded in epoxy. The potting material stabilizes the construction and assists in dissipating heat, generated during pulsation of the transducer element array, away from the probe surface/transducer face toward the interior/rear of the probe.

[0011] Conventional thermal management in ultrasound probes is accomplished with relatively simple devices such as heat pipes, which are buried in the transducer structure so that they transfer heat from the source into the body of the probe structure as quickly as possible. In this way heat is piped from the critical front surface of the probe into the handle where the increased

mass helps dissipate the heat evenly.

[0012] Ultrasonic transducer technology is rapidly evolving towards probes with higher element counts. This in turn requires more cabling and lighter-weight materials, and challenges the manufacturability of the interconnect between the individual elements and the ultrasonic imaging system. Added to this strain on the packaging technology is the availability of high levels of circuit integration in semiconductors. Because of the electrical impedance mismatch between the small elements in the transducer and the sensing electronics in the system, a number of investigators have developed means to provide active electronics within the transducer handle. As electronic technology advances, it is expected that more active circuitry will be placed as near to the source of the detected signal as possible.

[0013] The application of semiconductor technology to the diagnostic ultrasonic transducer has created a new dimension in the design and fabrication of these devices. Whereas these products have traditionally been composed of passive electronic circuits and sensors of piezoelectric ceramic, the transducer is now host to active preamplifiers, transmitters, lasers, and ultimately, A/D converters and perhaps digital signal processing. The addition of this technology into the traditionally "hand-held" ultrasonic probe creates severe strains on the ability of the mechanical designer to dispose of the heat generated by the active devices, thereby exacerbating the difficulty of thermal management within the transducer. In order to make the highest quality images, the power output of the probe is managed close to the regulatory limit, creating a need to manage the thermal output of the probe.

[0014] Thus, with the advent of active devices, the above-described use of heat pipes will no longer be sufficient to handle the heat load within the transducer. For example, the heat load dissipated by the simple devices available today is approximately 1 W. If preamplifiers are introduced into the system which dissipate 10 mW in a quiescent mode, the heat load will be increased by 2 W for a 200-element probe. Because the current designs are sometimes limited by the temperature of the patient contact area, there is little margin to accommodate this type of thermal output increase. Thus, there is a need to provide thermal transfer mechanisms capable of dissipating greater amounts of heat.

[0015] The present invention is an Ultrasonic probe according to claim 1. The invention is based on the concept of using the coaxial cable as a tool in managing the thermal problem created by the incorporation of active electronics in the handle of an ultrasonic probe. In accordance with preferred embodiments of the invention, the cable components are used as heat pipes which conduct heat out of the probe handle. These heat pipes are coupled to an internal heat pipe, made of a sheet or plate of heat conductive material, which is embedded in the backing layer material of a transducer pallet. Thus, heat generated by the transducer array can be trans-

ferred, via the internal heat pipe and the cable heat pipes, away from the probe surface which contacts the patient.

[0016] The cable assembly in an ultrasonic probe is composed of multiple coaxial cables bundled together and covered with an overall braided shield. Each individual coaxial cable comprises a plurality of individual conductors surrounded by a twisted shield. In accordance with the thermal management design of the invention, these heat conductive structures can serve as thermal transfer devices when thermally coupled to an internal heat pipe of the probe handle. Alternatively, a heat conductive structure can be embedded in the overall shield braid of the cable. Suitable heat conductive structures include thread or wire made of material having a high coefficient of thermal conductivity, as well as narrow tubing filled with heat conductive fluid.

[0017] In accordance with a further aspect of the present invention, inlet and return flow paths for cooling fluid are incorporated in the cable. The inlet and return flow paths inside the cable are respectively connected to the inlet and outlet of a flow path which is in heat conductive relationship with an internal heat pipe in the probe handle. In the case of forced recirculation, the cooling fluid is pumped from the cable return flow path to the cable inlet flow path. Alternatively, recirculation can be induced by cooling a portion of the cable flow path formed by connecting the cable return flow path directly to the cable input flow path, thereby generating a thermal gradient which draws heat out of the probe handle.

[0018] Thus, the invention solves the problem of how to transfer heat out of the probe handle in a manner so that the temperature of the probe part which contacts the patient does not exceed a predetermined upper limit. In particular, the invention provides a mechanism for dissipating heat generated inside the probe handle in a manner that leaves the patient unaware of the heating effect.

[0019] Embodiments of the invention will now be described, by way of example, with reference to the accompanying drawings, in which:-

FIG. 1 is a schematic exploded view of parts of a conventional transducer pallet for use in an ultrasonic probe.

FIG. 2 is a schematic diagram showing the structure of an ultrasonic probe in accordance with a first preferred embodiment of the invention wherein the transducer pallet is thermally coupled to the cable via a soldered internal heat pipe.

FIG. 3 is a schematic diagram showing on a magnified scale the handle of the ultrasonic probe shown in FIG. 2.

FIGS. 4A through 4F are schematic diagrams showing six variations of the internal heat pipe configuration in accordance with the preferred embodiments of the invention.

FIG. 5 is a schematic diagram showing the probe handle of an ultrasonic probe in accordance with a second preferred embodiment of the invention wherein the transducer pallet is thermally coupled to the cable via a passive fluid coupling.

FIGS. 6A and 6B are schematic diagrams showing the probe handle and system connector, respectively, of an ultrasonic probe in accordance with a third preferred embodiment of the invention wherein the transducer pallet is thermally coupled to the cable via an active fluid coupling.

FIG. 7 is a schematic sectional view showing the cable of an ultrasonic probe in accordance with a fourth preferred embodiment of the invention wherein heat pipes are embedded in a cable shield. FIG. 8A is a schematic diagram showing the armored cable of an ultrasonic probe in accordance with a fifth preferred embodiment of the invention wherein heat pipes are molded into the cable armor. FIG. 8B is a sectional view of the armor incorporated in the probe shown in FIG. 8A.

FIG. 9 is a schematic diagram showing the probe handle of an ultrasonic probe in accordance with a sixth preferred embodiment of the invention wherein the transducer pallet is thermally coupled to the cable via a semiconductor chiller.

[0020] Referring to FIG. 2, an ultrasound probe in accordance with the preferred embodiment of the invention comprises a probe handle 14 connected to one end of a cable 16 and a system connector 18 connected to the other end of the cable. Means 20 and 22 for relieving stress are provided at the cable/housing and system connector/cable connections, respectively. The probe handle 14 comprises a plastic shell 24 which houses a conventional transducer pallet 2. The system connector comprises a plastic housing 26 in which a PCB 28 is mounted. The signal electrodes of the transducer array are electrically connected to PCB 28 via flexible PCB 6, signal wiring 30 and a multiplicity of coaxial cables in cable 16.

[0021] As shown on a magnified scale in FIG. 3, the probe handle 14 in accordance with a first preferred embodiment of the invention comprises a transducer pallet 2 mounted in plastic shell 24. The pallet is arranged so that the front face of the transducer array is acoustically coupled to a cylindrical focusing lens 32 which contacts the patient. The transducer pallet 2 and focusing lens 32 are mounted inside plastic shell 24 by adhesively bonding the perimeter of lens 32 in an opening of corresponding shape formed in one end of shell 24. The other end of shell 24 is attached to the cable jacket 34. In accordance with the first preferred embodiment, at least one internal heat pipe 36, made of a material having a relatively high coefficient of thermal conductivity, is thermally coupled to a central portion of the transducer pallet. In addition, external heat pipes 38a and 38b (which may also serve the function of providing electro-

magnetic shielding) are placed in heat conductive relationship with the lateral periphery of the pallet.

[0022] The signal electrodes of the transducer array are electrically connected to the central conductors (not shown in FIG. 3) of respective coaxial cables via conductive traces formed on flexible PCB 6 and via signal wiring 30. In this embodiment, the cable overall (braided) shield 40 is brought into the probe handle 14 through the cable strain relief and directly soldered to the heat pipe structure 36 that is connected to pallet 2. The solder bead is indicated by numeral 42 in FIG. 3. This provides the most direct and effective method of piping heat from the source into the extended heat sink formed by the cable. Likewise the external heat pipes 38a and 38b are soldered to the cable overall shield 40. The cable comprises a bundle of coaxial cables surrounded by the overall shield. In addition to (or as an alternative to) thermally coupling the internal heat pipe to the overall shield, the internal heat pipe can be thermally coupled to the shield braid of each coaxial cable in the bundle.

[0023] The internal heat pipe 36 may comprise a flexible sheet or stiff plate of heat conductive material having one of the configurations depicted in FIGS. 4A, 4B and 4C. The configurations depicted in FIGS. 4B and 4C comprise respective flat heat pipes 36' and 36", each having a comb-like structure which is thermally coupled to the transducer pallet by embedding the comb fingers in the backing material.

[0024] In accordance with a second preferred embodiment shown in FIG. 5, the transducer pallet 2 is thermally coupled to the cable shield braid 40 via a passive fluid coupling comprising a cable fluid path 44 incorporated in the cable bundle, a fluid channel 46 mounted on and thermally coupled to the internal heat pipe 36, and a coupling joint 48 for connecting cable fluid path 44 to fluid channel 46. The fluid channel 46 may take the form of a U-shaped pipe as seen in FIG. 4D, while the cable fluid path is a pipe incorporated in the cable bundle and thermally coupled to the cable shield braid. In the latter case, the coupling joint 48 takes the form of a straight pipe in fluid communication with the ends of the legs of the U-shaped fluid channel and with an end of the cable fluid path 44, as seen in FIG. 4D. Each pipe 44, 46 and 48 may be a plastic or metal tube filled with a fluid having a relatively high thermal conductivity. Liquid metals, for example, could be used in this application provided that sufficient precautions were taken to maintain patient safety. In this embodiment, the pipes are passive, i.e., heat is transferred into the pipes passively and transferred throughout the cable without fluid motion.

[0025] In accordance with a third preferred embodiment shown in FIGS. 6A and 6B, the transducer pallet 2 is thermally coupled to the cable shield braid 40 via an active fluid coupling comprising an input cable fluid path 50 and a return cable fluid path 52 both incorporated in the cable bundle, a fluid channel 54 mounted on and thermally coupled to the internal heat pipe 36, and

coupling joints 56 and 58 for respectively connecting the input and return cable fluid paths to fluid channel 54. Like the fluid channel 46 incorporated in the embodiment of FIG. 5, the fluid channel 54 may take the form of a U-shaped pipe as seen in FIG. 4E, while the input and return cable fluid paths are respective pipes incorporated in the cable bundle and thermally coupled to the cable shield braid. One end of the input cable fluid path 50 is in fluid communication with an input leg of fluid channel 54; the end of the return cable fluid path 52 is in fluid communication with an output leg of fluid channel 54. The input and out-put legs of fluid channel 54 may be mounted on the same side (as shown in FIG. 4E) or on opposite sides of the internal heat pipe 36 (as shown in FIG. 6A). In the latter case, part of the U-shaped fluid channel is embedded in the backing material. Each pipe 50, 52 and 54 may be a plastic or metal tube filled with fluid having a high thermal conductivity.

[0026] The third preferred embodiment utilizes active movement, i.e., recirculating flow, of the cooling fluid in cooling pipes to cool the probe handle. This might be accomplished with a small micromotor 60 (see FIG. 6B) powered by the system. The micromotor 60 drives a pump 62 which pumps cooling fluid from a cooling fluid input line 64 to a cooling fluid output line 66 arranged inside the system connector 18. The cooling fluid input line 64 is in flow communication with the return cable fluid path 52 and the cooling fluid output line 66 is in flow communication with the input cable fluid path 50. Thus, pump 62, cooling fluid output line 66, input cable fluid path 50, fluid channel 54, return cable fluid path 52 and cooling fluid input line 64 form a closed circuit for recirculating flow of cooling fluid. As an alternative to the use of a motor to drive recirculation of the cooling fluid, recirculating flow may be driven by active cooling of a portion of the fluid circuit, thereby generating a thermal gradient which draws heat out of the probe handle. In either case, energy is expended in order to create cooling in the transducer handle.

[0027] A variation on the active fluid coupling embodiment is to eliminate the internal heat pipe and simply embed the curved part of the U-shaped fluid channel 46 (see FIG. 4F) in the backing material.

[0028] In accordance with a fourth preferred embodiment shown in FIG. 7, a plurality of heat pipes 68 are implanted in the overall braid or shield 40 of the cable assembly. The overall shield 40 is in the shape of a braided annulus bounded by the cable jacket 34 on an outer periphery and by an internal sheath 70 on an inner periphery. The internal sheath 70 surrounds a bundle of coaxial cables 72. Each coaxial cable in turn comprises a jacket 74, braided shielding 76, dielectric 78 and a center conductor 80 arranged in well-known manner. The cable shield heat pipes 68 may be circumferentially distributed at equal angular intervals around the overall shield 40. The heat pipes may be made of any suitable material having a high coefficient of thermal conductivity, including gold threads woven into the overall braid

(selected heat pipes with high coefficients of thermal conductivity) or a tube filled with fluid.

[0029] In the case of armored cable of the type shown in FIG. 8A, the bundle of coaxial cables is surrounded by a spiral armor 82. The armor cross section can be molded to provide one or more channels, which are filled with heat conductive material for transporting heat along the cable and away from the probe handle. Alternatively, as best seen in FIG. 8B, the armor can be molded to provide input and return channels 84a, 84b for recirculating fluid used to cool the transducer pallet.

[0030] Finally, in accordance with a sixth preferred embodiment shown in FIG. 9, a semiconductor chiller 86 is mounted in heat conductive relationship with the transducer pallet 2. Then an arrangement similar to that shown in FIGS. 6A and 6B is used to pipe the heat generated by the semiconductor chiller 86 to the outside environment. In this case, however, the internal heat pipe 36 is placed in heat conductive relationship with the semiconductor chiller 86, instead of being thermally coupled to the transducer pallet directly.

Claims

1. An ultrasonic probe comprising a probe handle (14) and a cable (16) connected thereto, said cable comprising a heat conductive structure (44, 68, 76 or 84) extending along a length of said cable, and said probe handle comprising a transducer pallet (2) and a heat pipe (36, 38a, 38b) and said heat pipe (36, 38a, 38b) being in heat conductive relationship with a portion of said transducer pallet (2) and thermally coupled to said heat conductive structure (44, 68, 76 or 84) in said cable, **characterised in that** said heat conductive structure (44, 68, 76 or 84) comprises a spiral armour (82) molded to provide one or more channels (84a, 84b) filled with heat conductive fluid.
2. The ultrasonic probe as defined in claim 1, **characterized in that** said probe handle further comprises a first tube (46) attached to said heat pipe.
3. The ultrasonic probe as defined in claim 4, **characterized in that** said heat conductive structure comprises a second tube (44) in flow communication with said first tube.
4. The ultrasonic probe as defined in claim 4, **characterized in that** said first tube has an inlet and an outlet, and said heat conductive structure comprises a second tube (50) in flow communication with said inlet of said first tube and a third tube (52) in flow communication with said outlet of said first tube.
5. The ultrasonic probe as defined in claim 6, further

characterized by a pump (60) and a motor (62), wherein said second tube is in flow communication with said third tube via said pump.

6. The ultrasonic probe as defined in claim 6, further **characterized by** a semiconductor chiller (86) arranged to extract heat from said transducer pallet and transfer extracted heat to said heat pipe. 5
7. The ultrasonic probe as defined in claim 1 **characterized in that** an acoustic damping material is acoustically coupled to a rear face of said transducer pallet. 10
8. The ultrasonic probe as defined in claim 9 **characterized in that** said heat pipe has a portion embedded in said damping material. 15
9. The ultrasonic probe as defined in claim 1 **characterized in that** said cable comprises a bundle of coaxial cables (72) and an overall shield (40) surrounding said bundle. 20

Patentansprüche

1. Ultraschallsonde enthaltend einen Sondengriff (14) und ein damit verbundenes Kabel (16), wobei das Kabel eine wärmeleitende Struktur (44,68,76 oder 84) aufweist, die sich entlang einer Länge des Kabels erstreckt, und der Griff eine Wandlerplatte (2) und eine Wärmeleitung bzw. Heat Pipe (36,38a, 38b) aufweist und die Wärmeleitung (36,38a,38b) in wärmeleitender Relation zu einem Teil der Wandlerplatte (2) ist und mit der wärmeleitenden Struktur (44,68,76 oder 84) in dem Griff thermisch gekoppelt ist, **dadurch gekennzeichnet, daß** die wärmeleitende Struktur (44,68,76 oder 84) eine wendelförmige Armierung (82) aufweist, die so geformt ist, daß sie einen oder mehr Kanäle (84a,84b) bildet, die mit wärmeleitendem Fluid gefüllt ist. 25 30
2. Ultraschallsonde nach Anspruch 1, **dadurch gekennzeichnet, daß** der Sondengriff ferner eine erste Röhre (46) aufweist, die an der Wärmeleitung befestigt ist. 35 40
3. Ultraschallsonde nach Anspruch 2, **dadurch gekennzeichnet, daß** die wärmeleitende Struktur eine zweite Röhre (44) in Strömungsverbindung mit der ersten Röhre aufweist. 45 50
4. Ultraschallsonde nach Anspruch 2, **dadurch gekennzeichnet, daß** die erste Röhre einen Einlass und einen Auslass hat, und die wärmeleitende Struktur eine zweite Röhre (50) in Strömungsverbindung mit dem Einlass der ersten Röhre und eine dritte Röhre (52) in Strömungsverbindung mit dem 55

Auslass der ersten Röhre hat.

5. Ultraschallsonde nach Anspruch 4, **gekennzeichnet durch** eine Pumpe (60) und einen Motor (62), wobei die zweite Röhre mit der dritten Röhre über die Pumpe in Strömungsverbindung ist.
6. Ultraschallsonde nach Anspruch 4, ferner **gekennzeichnet durch** einen so angeordneten Halbleiter-Kühler (86), daß er der Wandlerplatte Wärme entzieht und die entzogene Wärme auf die Wärmeleitung überträgt.
7. Ultraschallsonde nach Anspruch 1, **dadurch gekennzeichnet, daß** ein akustisches Dämmmaterial mit der Rückfläche von der Wandlerplatte akustisch gekoppelt ist.
8. Ultraschallsonde nach Anspruch 7, **dadurch gekennzeichnet, daß** die Wärmeleitung einen Abschnitt hat, der in das Dämmmaterial eingebettet ist.
9. Ultraschallsonde nach Anspruch 1, **dadurch gekennzeichnet, daß** das Kabel ein Bündel von Koaxialkabeln (72) und eine Gesamtabschirmung (40) aufweist, die das Bündel umgibt. 25

Revendications

1. Sonde à ultrasons comprenant une poignée (14) de sonde et un câble (16) connecté à celle-ci, ledit câble comprenant une structure conductrice de chaleur (44, 68, 76 ou 84) s'étendant le long d'une longueur dudit câble, et ladite poignée de sonde comprenant une plaque de transducteur (2) et un tuyau de chaleur (36, 38a, 38b) et ledit tuyau de chaleur (36, 38a, 38b) étant en relation de conduction de chaleur avec une partie de ladite plaque de transducteur (2) et couplé thermiquement à ladite structure conductrice de chaleur (44, 68, 76 ou 84) dans ledit câble, **caractérisée en ce que** ladite structure conductrice de chaleur (44, 68, 76 ou 84) comprend une armure en spirale (82) moulée pour fournir un ou plusieurs canaux (84a, 84b) remplis de fluide conducteur de chaleur. 30 35 40
2. Sonde à ultrasons selon la revendication 1, **caractérisée en ce que** ladite poignée de sonde comprend en outre un premier tube (46) attaché audit tuyau de chaleur. 45 50
3. Sonde à ultrasons selon la revendication 2, **caractérisée en ce que** ladite structure conductrice de chaleur comprend un deuxième tube (44) en communication de fluide avec ledit premier tube. 55

4. Sonde à ultrasons selon la revendication 2, **carac-**
térisée en ce que ledit premier tube comporte un
orifice d'entrée et un orifice de sortie, et ladite struc-
ture conductrice de chaleur comprend un deuxième
tube (50) en communication de fluide avec ledit ori- 5
fice d'entrée dudit premier tube et un troisième tube
(52) en communication de fluide avec ledit orifice
de sortie dudit premier tube.
5. Sonde à ultrasons selon la revendication 4, **carac-** 10
térisée en outre par une pompe (60) et un moteur
(62), ledit deuxième tube étant en communication
de fluide avec ledit troisième tube via ladite pompe.
6. Sonde à ultrasons selon la revendication 4, **carac-** 15
térisée en outre par un refroidisseur à semicon-
ducteur (86) agencé pour extraire de la chaleur de
ladite plaque de transducteur et transférer la cha-
leur extraite audit tuyau de chaleur.
7. Sonde à ultrasons selon la revendication 1, **carac-** 20
térisée en ce qu'un matériau d'amortissement
acoustique est couplé acoustiquement à une face
arrière de ladite plaque de transducteur.
8. Sonde à ultrasons selon la revendication 7, **carac-** 25
térisée en ce que ledit tuyau de chaleur a une par-
tie enfoncée dans ledit matériau d'amortissement.
9. Sonde à ultrasons selon la revendication 1, **carac-** 30
térisée en ce que ledit câble comprend un faisceau
de câbles coaxiaux (72) et un blindage d'ensemble
(40) entourant ledit faisceau.

35

40

45

50

55

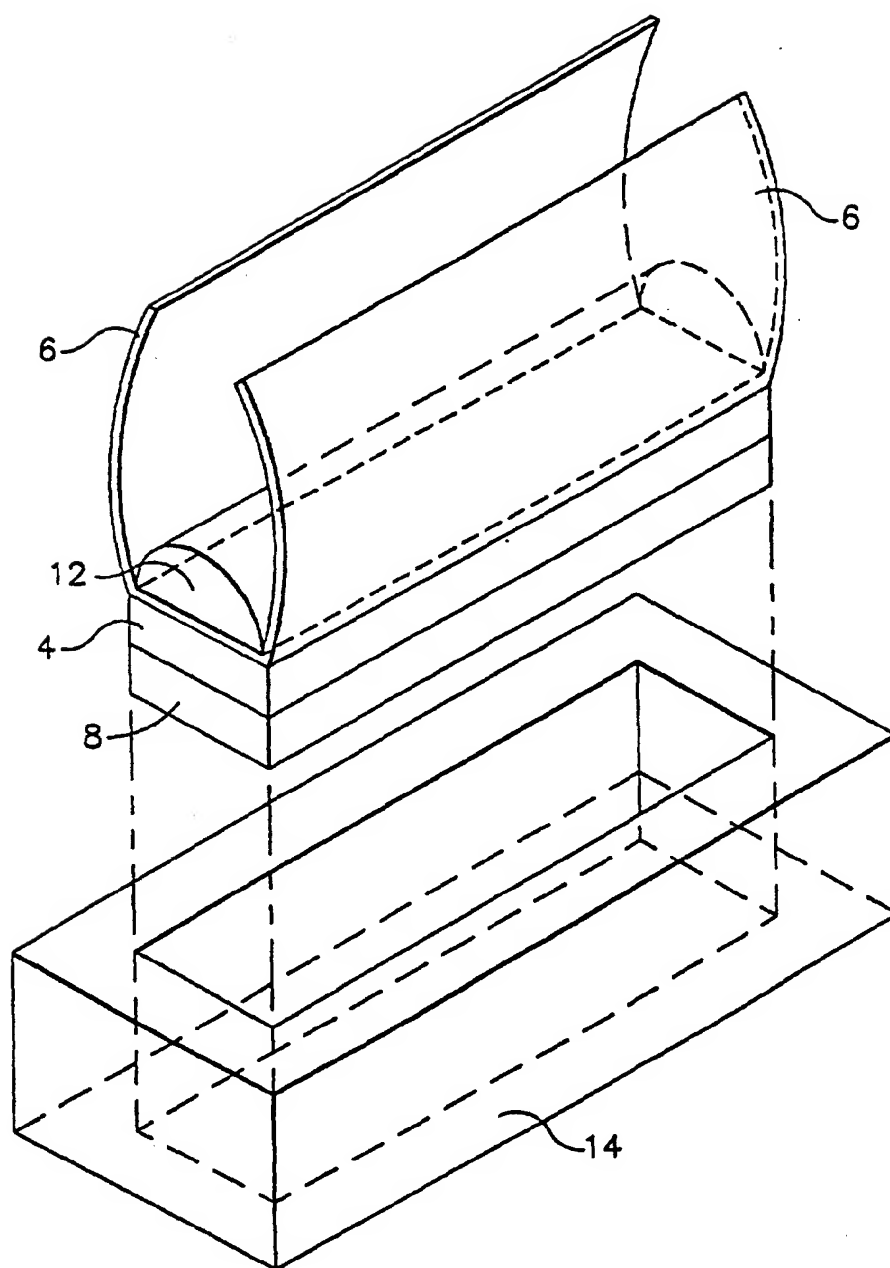


FIG. 1

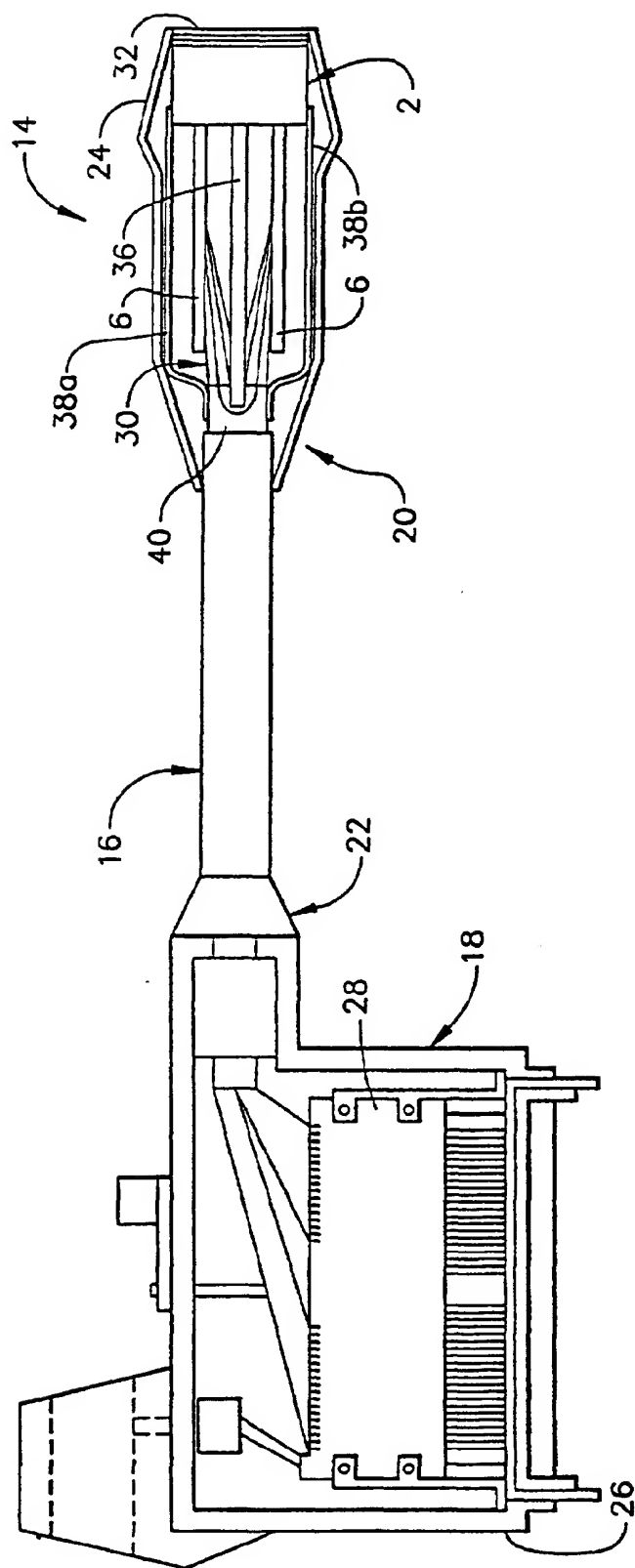


FIG. 2

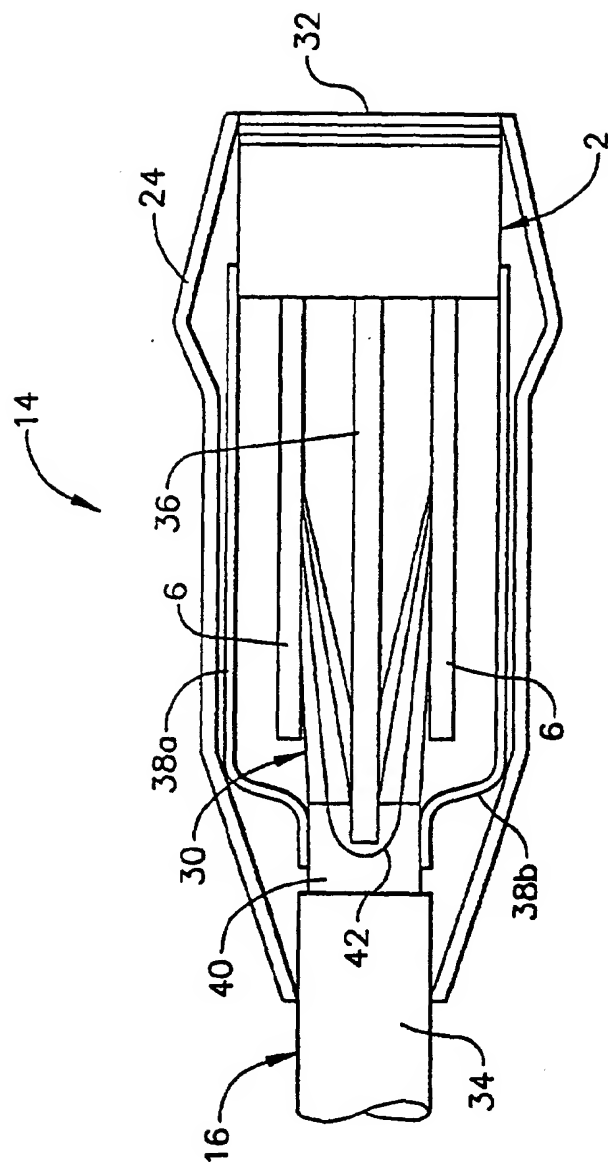


FIG. 3

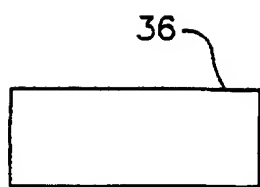


FIG. 4A

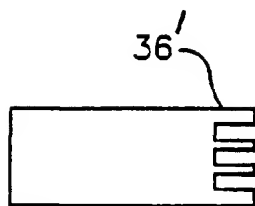


FIG. 4B

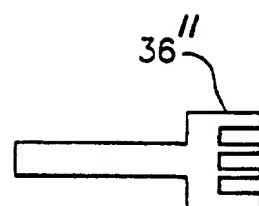


FIG. 4C

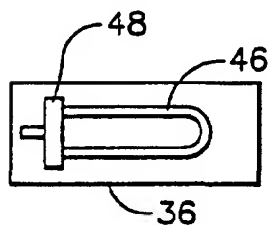


FIG. 4D

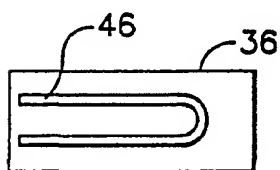


FIG. 4E

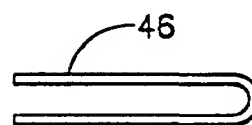


FIG. 4F

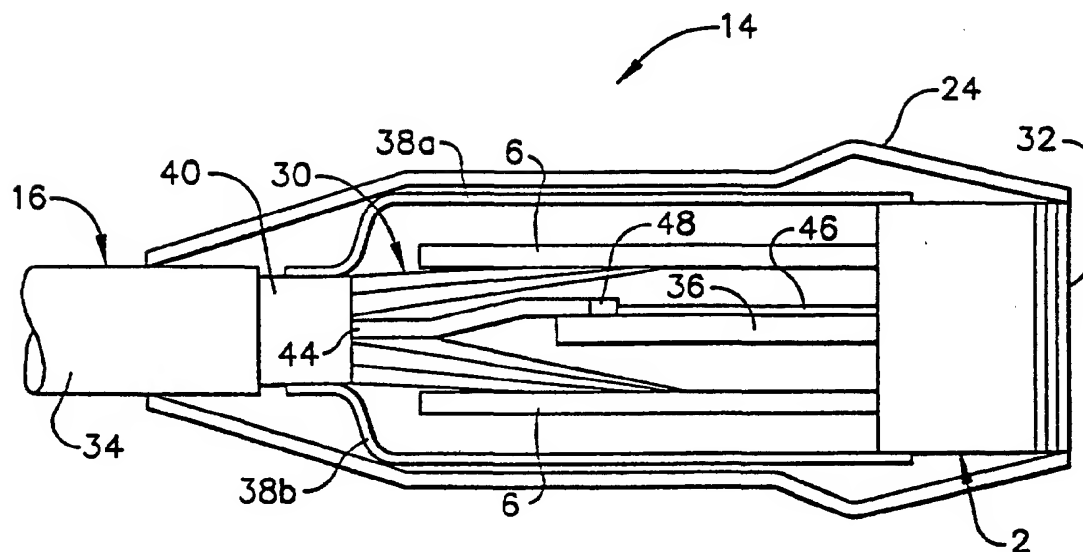


FIG. 5

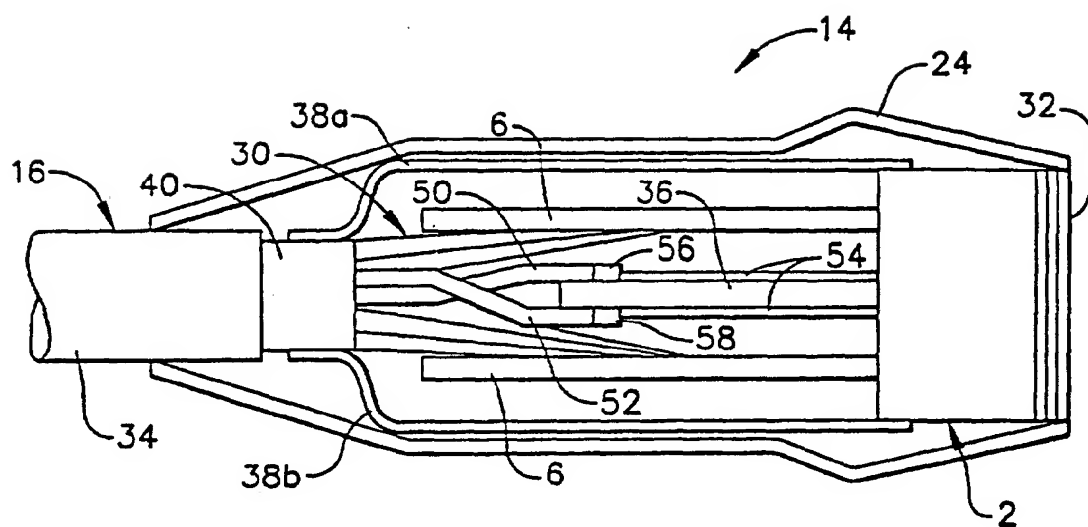


FIG. 6A

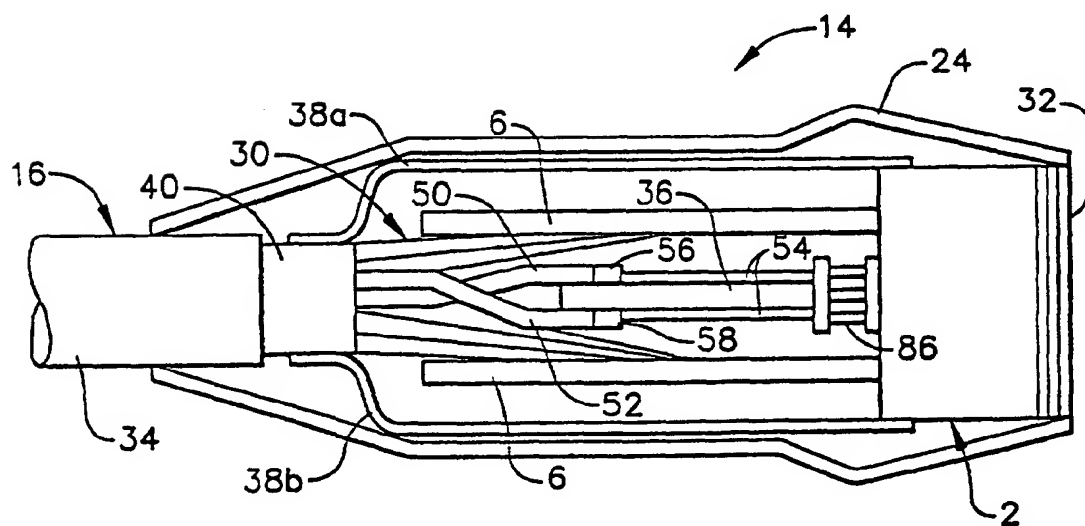


FIG. 9

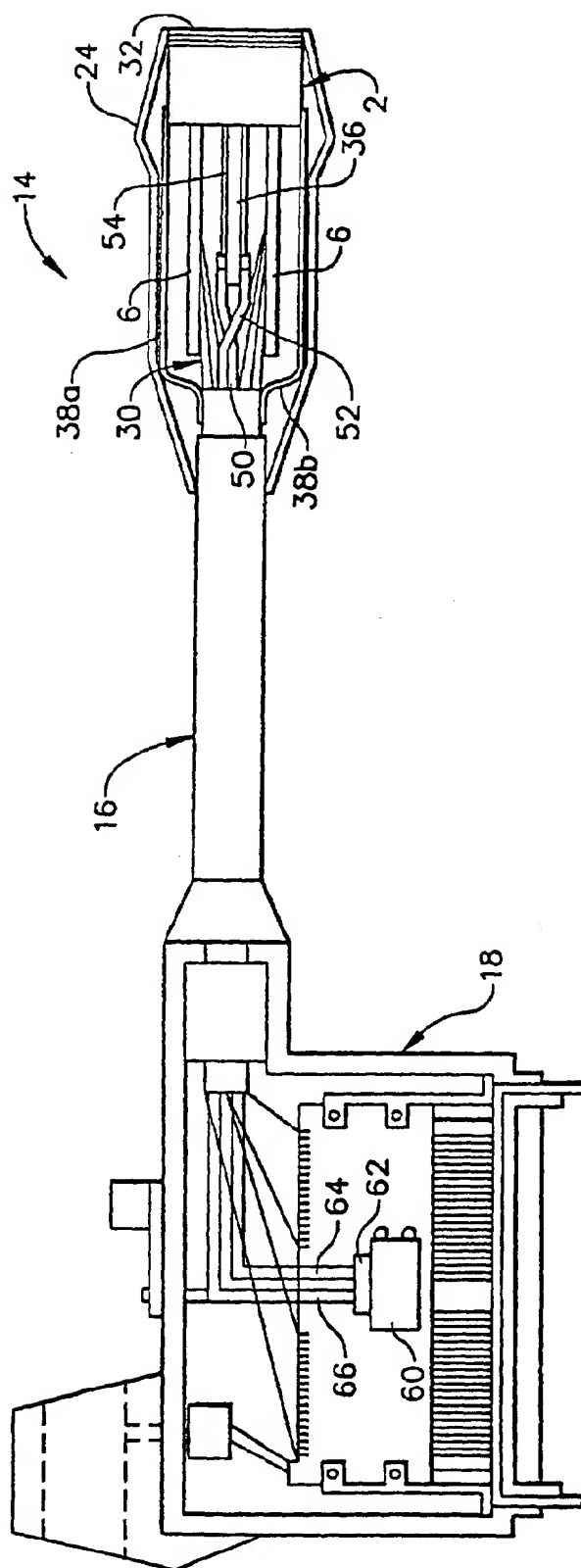


FIG. 6B

